

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hideshi NISHIKAWA et al.

Art Unit: not yet assigned

Application No.: not yet assigned

Examiner: not yet assigned

Filed: March 26, 2004

Attorney Dkt. No.: 12054-0025

For: SILICON ANNEALED WAFER AND SILICON EPITAXIAL WAFER

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 26, 2004

Sir:

Prior to examination on the merits of the above-identified application, please amend the application as set forth below.

Amendments to the claims are submitted on page 2.

Remarks are submitted on page 5.